

Resource Summary Report

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Stanford Nanofabrication Core Facility

RRID:SCR_023234

Type: Tool

Proper Citation

Stanford Nanofabrication Core Facility (RRID:SCR_023234)

Resource Information

URL: <https://snf.stanford.edu/>

Proper Citation: Stanford Nanofabrication Core Facility (RRID:SCR_023234)

Description: One of four labs that are part of nano@stanford, under NSF National Nanotechnology Coordinated Infrastructure program. SNF includes cleanroom housing tools for device fabrication, satellite labs supporting Metal Organic Chemical Vapor Deposition, Experimental Fabrication methods and electronics shop for Systems Prototyping. SNF supports researchers in applications ranging from medicine and biology to fundamental physics and astronomy.

Abbreviations: SNF

Synonyms: Stanford Nanofabrication Facility

Resource Type: core facility, service resource, access service resource

Keywords: USEdit, ABRF, National Nanotechnology Coordinated Infrastructure, Metal Organic Chemical Vapor Deposition, Experimental Fabrication, Systems Prototyping, device fabrication

Availability: Open

Resource Name: Stanford Nanofabrication Core Facility

Resource ID: SCR_023234

Alternate IDs: ABRF_2464

Alternate URLs: <https://coremarketplace.org/?FacilityID=2464&citation=1>,
https://coremarketplace.org/RRID:SCR_023234?citation=1

Record Creation Time: 20230204T050200+0000

Record Last Update: 20260731T043129+0000

Ratings and Alerts

No rating or validation information has been found for Stanford Nanofabrication Core Facility.

No alerts have been found for Stanford Nanofabrication Core Facility.

Data and Source Information

Source: [SciCrunch Registry](#)

Usage and Citation Metrics

We found 1 mentions in open access literature.

Listed below are recent publications. The full list is available at [dkNET](#) .

Pourmand N, et al. (2006) Direct electrical detection of DNA synthesis. Proceedings of the National Academy of Sciences of the United States of America, 103(17), 6466.